

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: ) Group Art Unit:  
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                                  Nozomu HOSHI ) Examiner:  
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Application No. )  
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Filed: )  
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For:    Semiconductor Laser Device and )  
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                                  Method for Fabricating Thereof )

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT PURSUANT TO 1.53(b)**

Dear Sir:

The above-identified application is a divisional of Application No. 09/580,961 filed May 30, 2000. Please amend the instant application as follows.